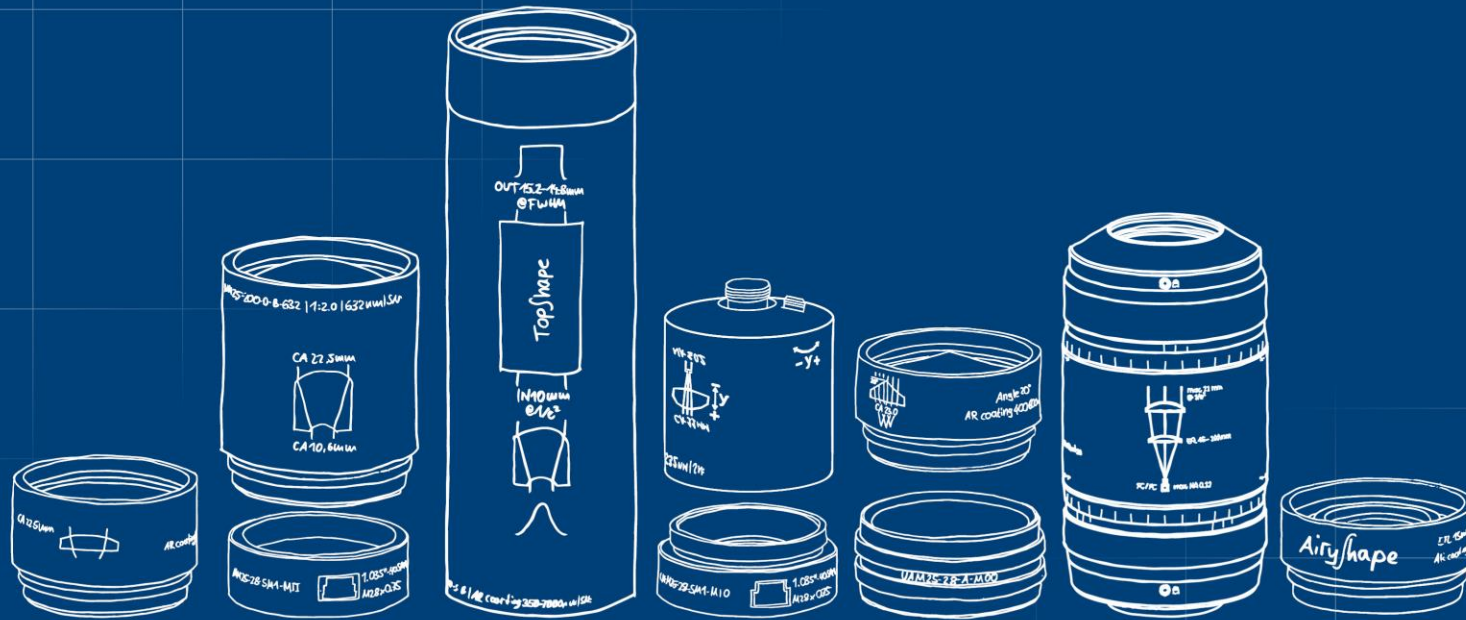




Revolutionizing Laser Systems

-

The Power of BeamTuning



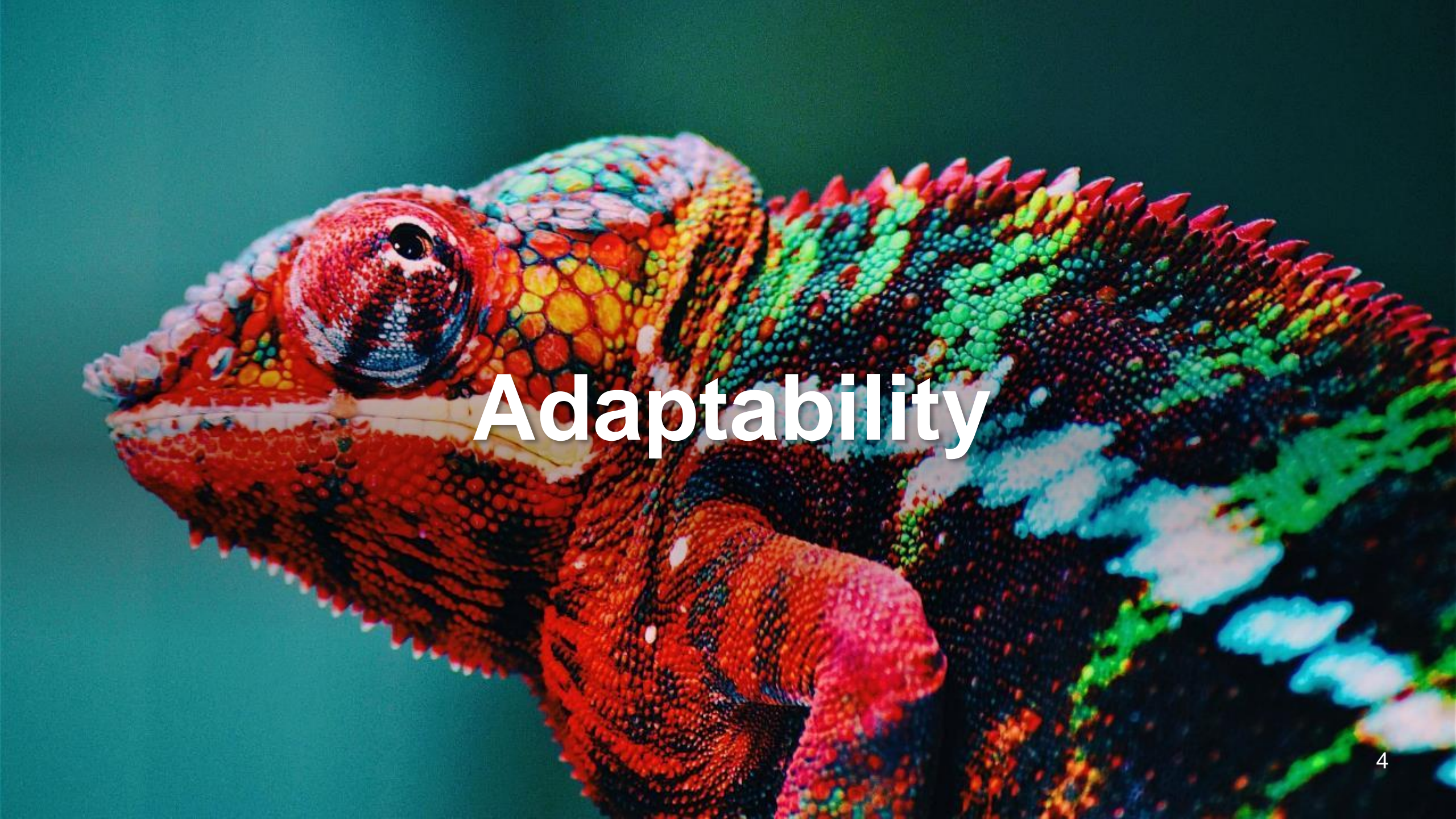
W3+ Fair – EPIC TechWatch

A stack of five colorful wooden blocks (black, green, red, blue, and black) is positioned in the background on a dark wooden surface. In the foreground, four wooden blocks are arranged in a row, each with a letter: 'P' (brown), 'L' (blue), 'A' (red), and 'Y' (green). The word 'Simplicity' is overlaid in the center in a large, white, sans-serif font.

Simplicity



Performance



Adaptability

asphericon BeamTuning



BEAM TU·NING [bi:m 'tju:nin] – TO ADJUST SOMETHING FOR MAXIMUM USABILITY AND PERFORMANCE



BeamExpansion

World's first aspheric beam expansion system



FiberCoupling

FiberCollimation, Fiber Coupling



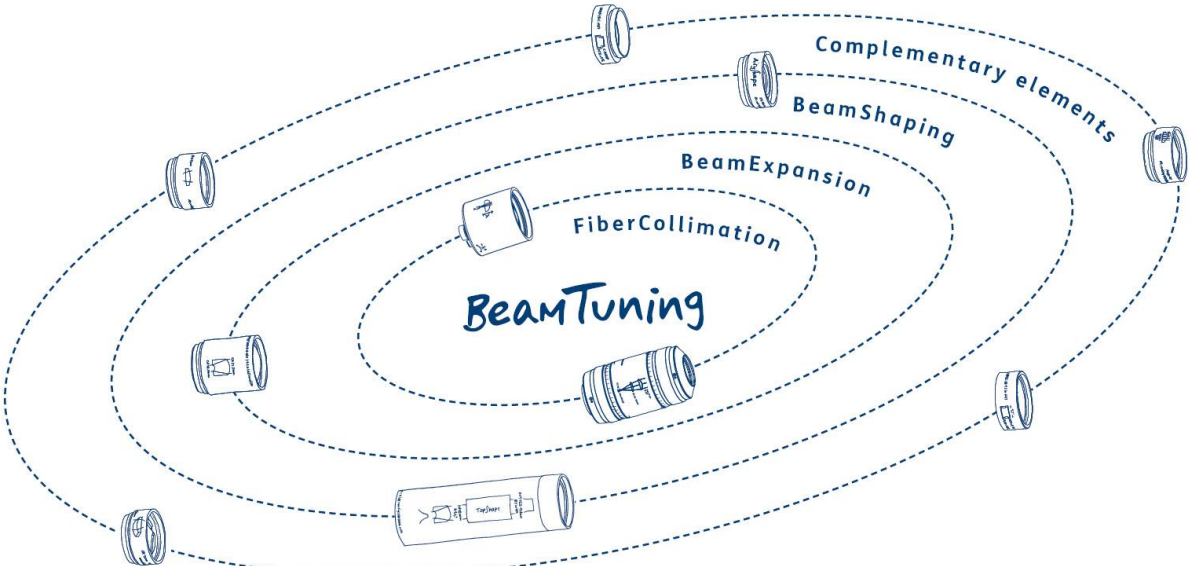
BeamShaping

Innovative beam shaper



Complements

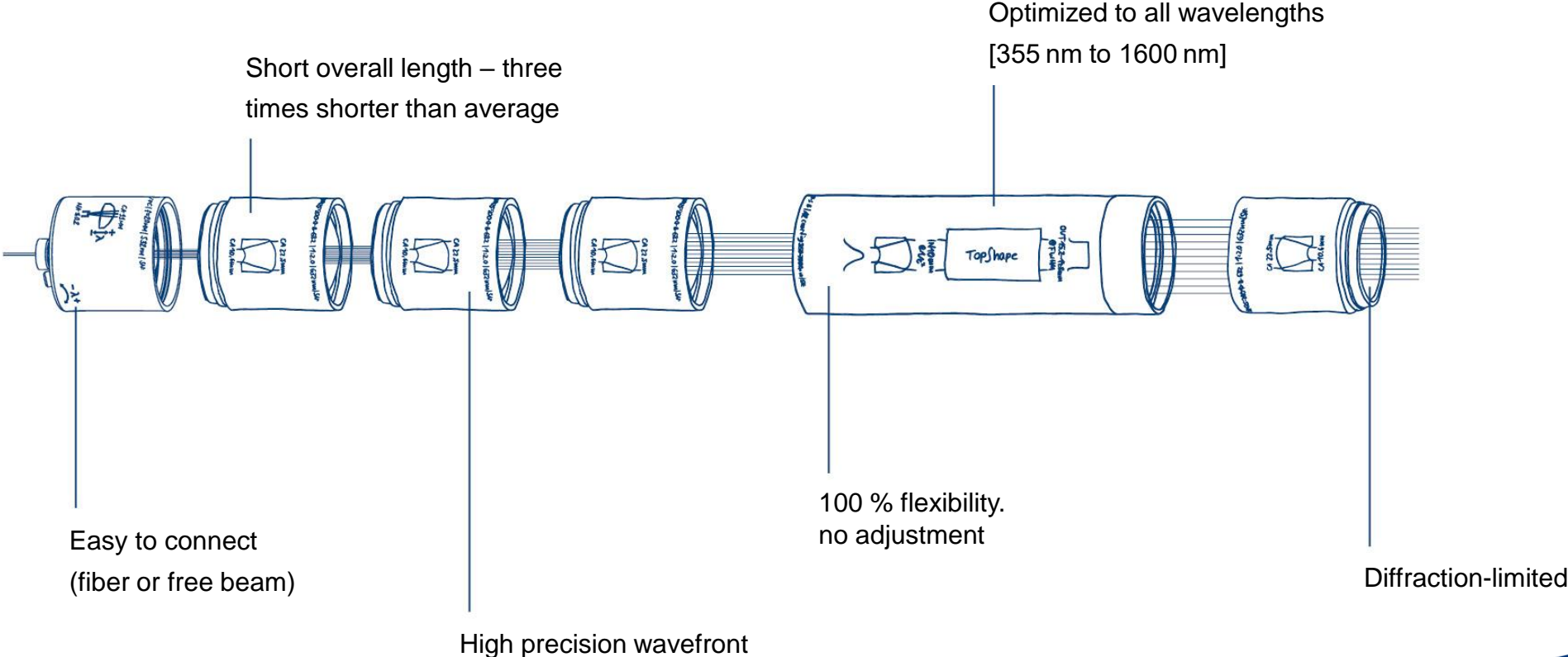
Adapters, MountedOptics Opto-Mechanicals



asphericon BeamTuning



FROM THE FIRST ASPHERIC BEAMEXPANDER TO A UNIQUE SYSTEM

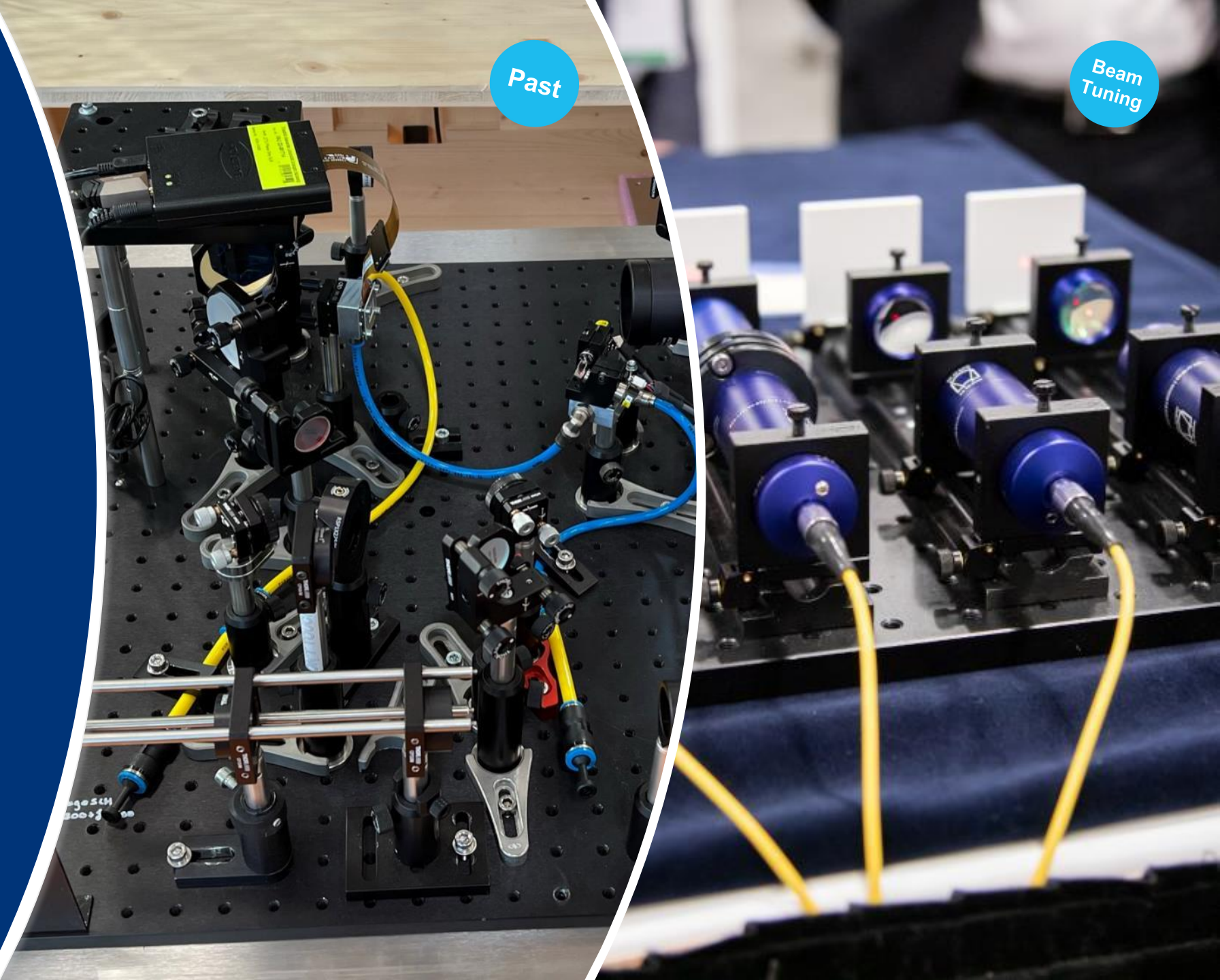


**Simplicity
Performance
Adaptability**

FROM COMPLEX & TIME
CONSUMING ALIGNMENT TO
EASY INTEGRATION

Past

Beam
Tuning



**Deep Dive into
our
BeamShaping
World**

asphericon BeamTuning



THE NEXT LEVEL OF REFRACTIV BEAM SHAPING



a|AiryShape

- = Generates different beam profiles (Top-Hat, Donut and Beam Waist)
- = Scalable input and output beam
- = Optimized for 300 nm – 1600 nm



a|SqAiryShape

- = Generates different squared Top-Hat beam profiles (Top-Hat, Donut and Beam Waist)
- = Profile size easily scalable by focal length
- = Optimized for 300 nm – 1600 nm



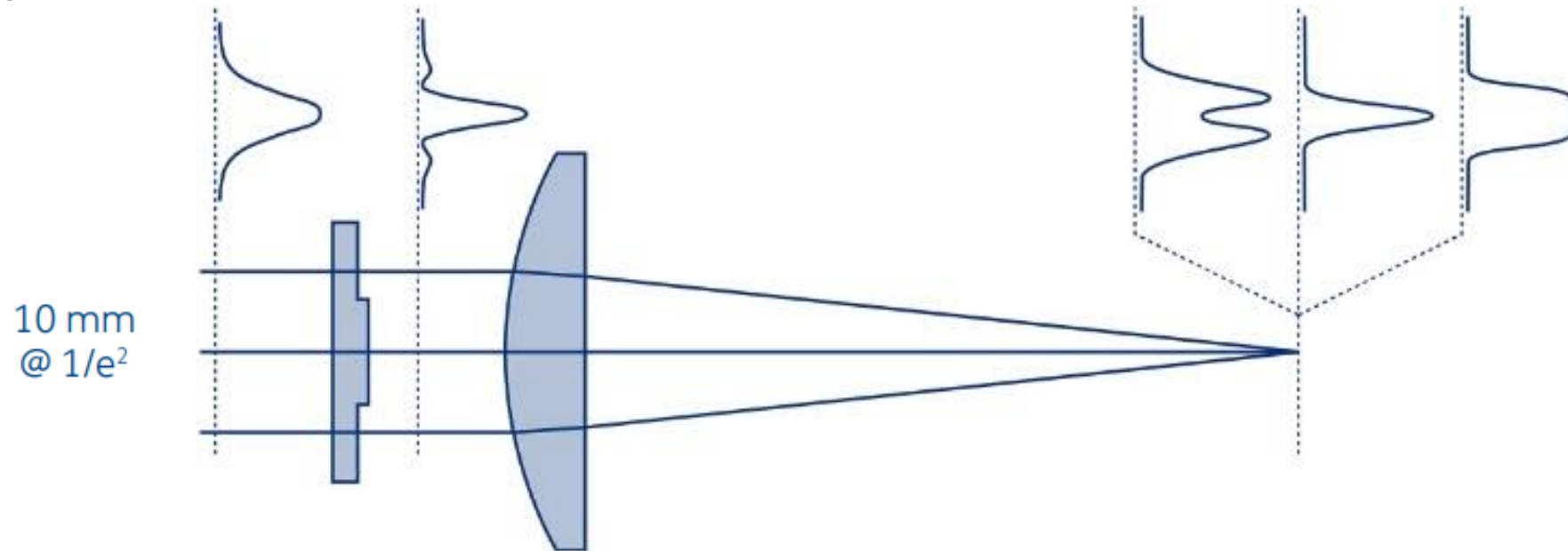
a|TopShape

- = Transforms collimated Gaussian beams into collimated Top-Hat beams (320 - 2500 nm)
- = Propagation depth (with beam uniformity < 0.1):
 - a|TopShape: At least 300 mm
 - a|TopShape LD: up to 1.5 m
 - a|TopShape LDX: At least 1.5 m, shiftable to longer working distances

a|AiryShape and a|SqAiryShape

BEAM SHAPING IN THE FOKUS

= The working principal

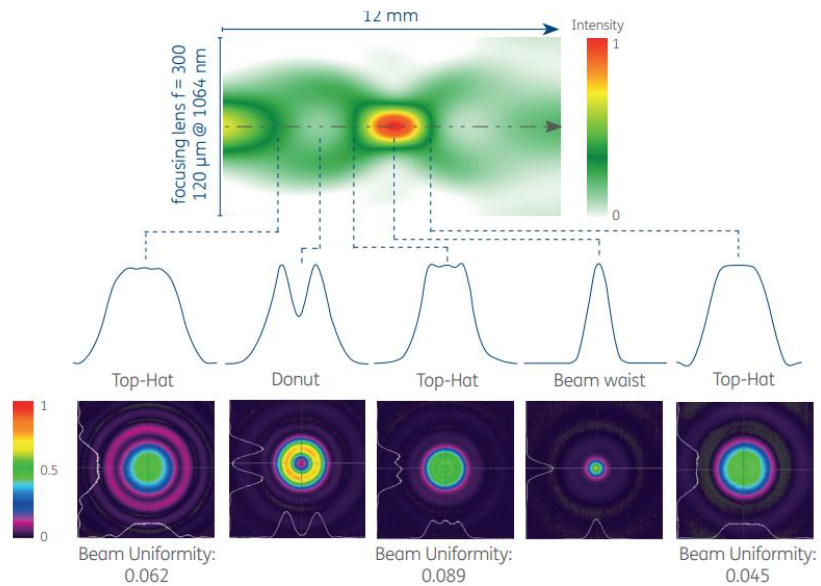


= The beam shapers a|AiryShape and a|SqAiryShape enable, in combination with a focusing lens, the transformation of collimated Gaussian beams into different focused round (a|AiryShape) and squared (a|SqAiryShape) beam profiles

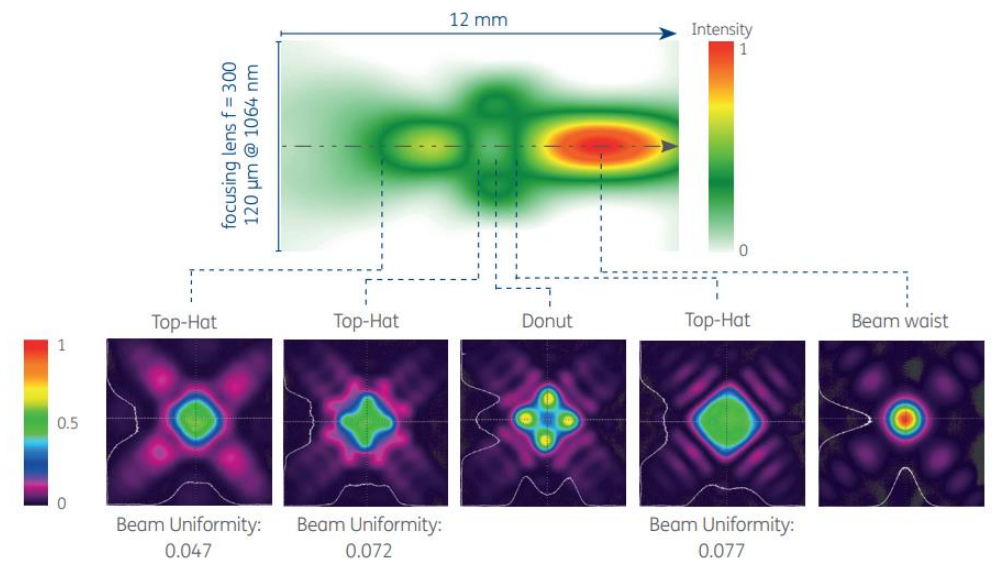
a|AiryShape and a|SqAiryShape

BEAM SHAPING IN THE FOKUS

= a|AiryShape BeamProfiles in the focal area

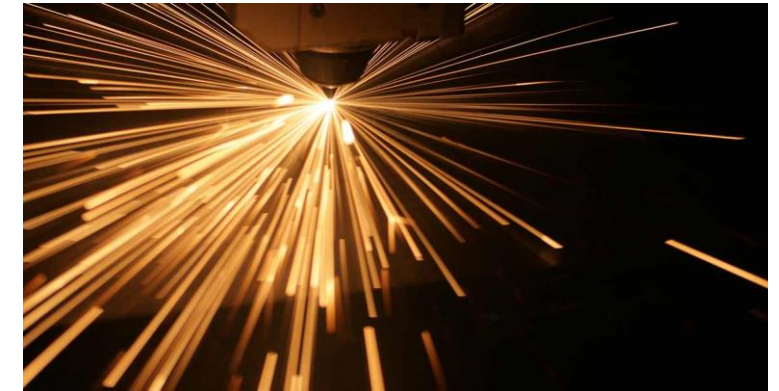
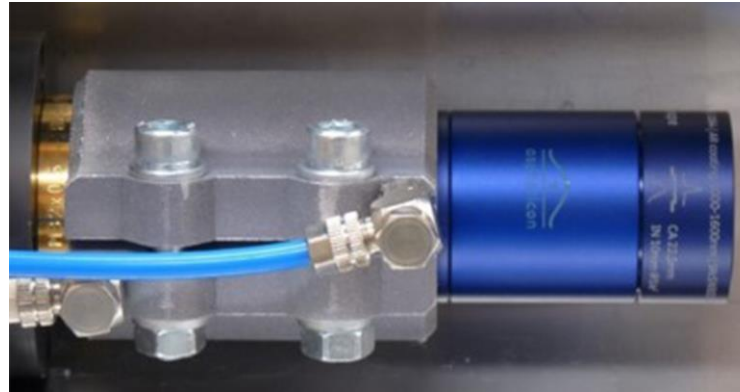
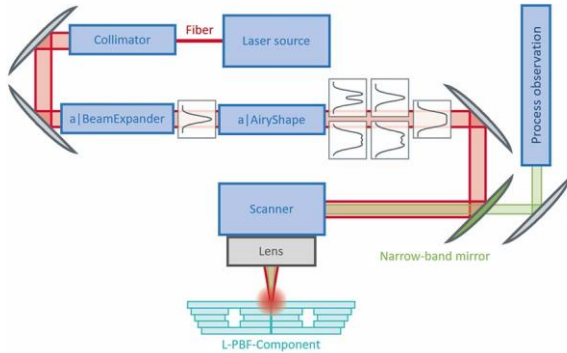


= a|SqAiryShape Beam Profiles in the focal area



Ifw – Beam shaper for laser welding

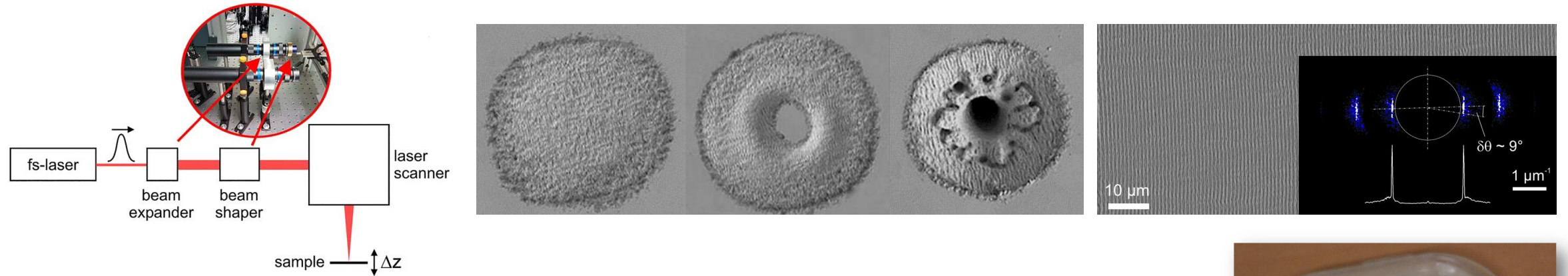
BEAMTUNING PRODUCTS FOR OPTIMIZED WELD SEAMS



- = Integration of a|BeamExpander (for beam expansion) and a|AiryShape (generation of different focused profiles, e.g. Top-Hat, Donut) into existing system technology
- = Improvement of process stability as well as outgassing behavior for generation of high-quality, pore-free and gas-tight weld seams (without edge/root notches)
- = Reduction of spattering and the production time

OSIM – Laser-induced structuring

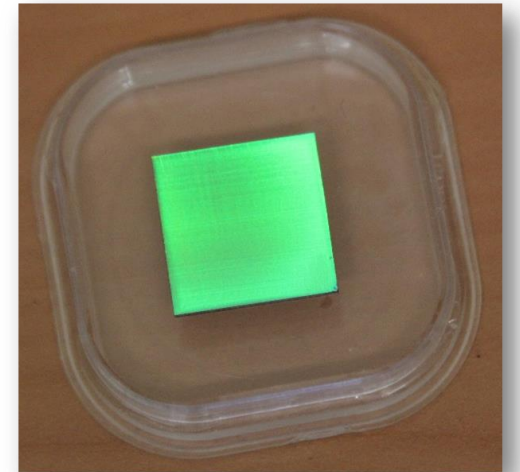
SURFACE FUNTIONALIZATION WITH TAILORED TOP-HATS



= Together with Otto-Schott-Institute für material research (OSIM) in Jena, impacts of Top-Hat intensity distributions were investigated with respect to their suitability for the generation of laser-induced periodic surface structures (LIPSS) on stainless steel

= Results:

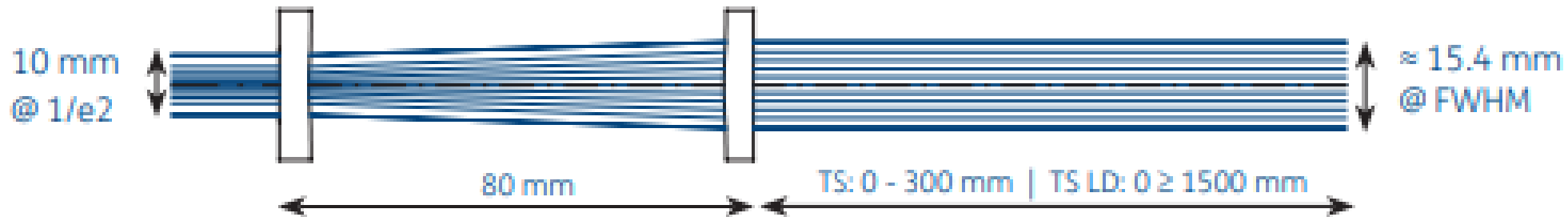
- Doubling of scanning velocity
- Reduction of processing time by a factor of 2 with constant surface structure quality



a|TopShape and a|TopShape LD

COLLIMATED BEAM SHAPING

= The working principal



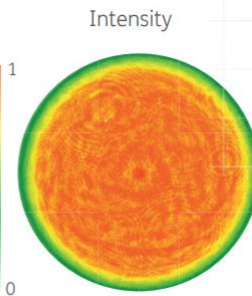
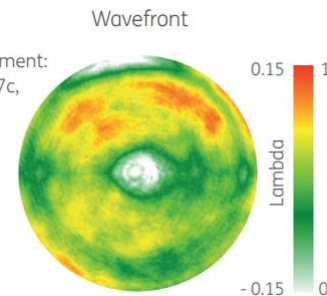
= The a|TopShape transforms collimated Gaussian beams into slightly enlarged ($M \approx 1.4$) collimated beams with a uniform intensity distribution

Measurement equipment:
Phasics SID4-HR-307c,
300x400 pts

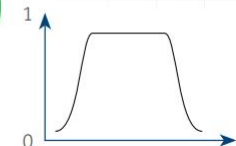
Wavelength:
780 nm

Wavefront RMS:
 0.05λ

Strehl:
0.9

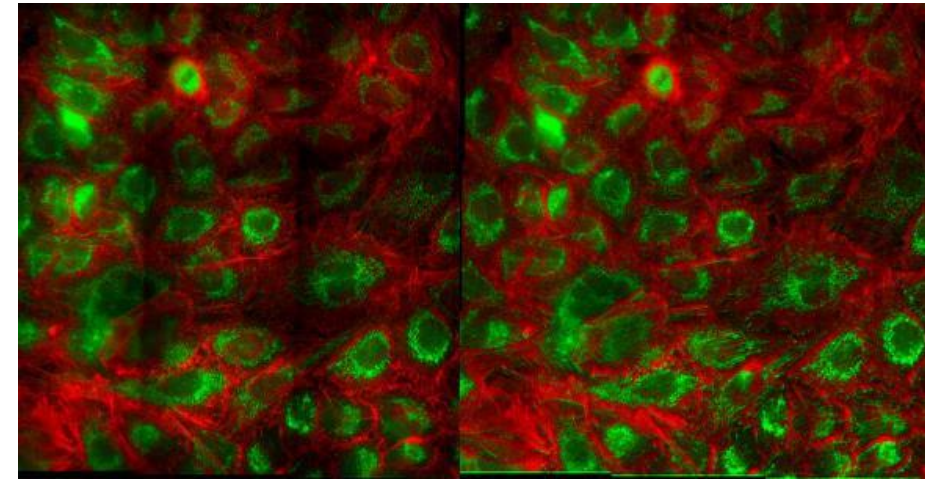
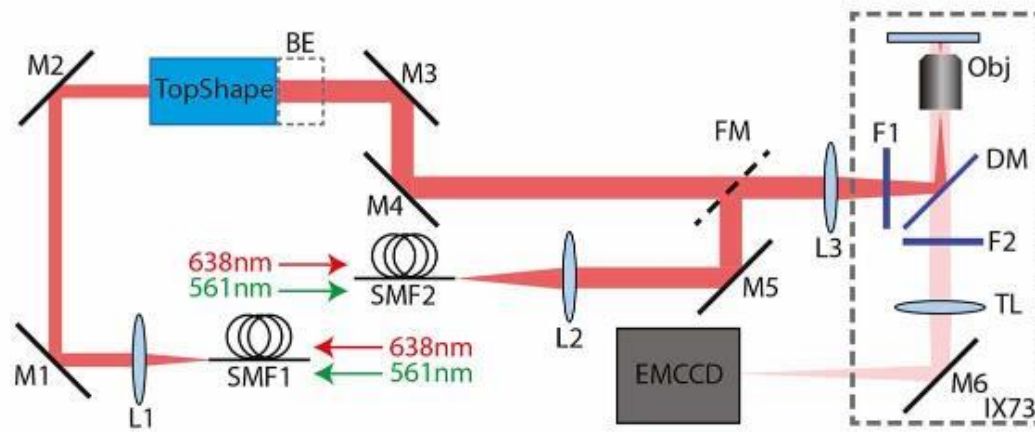


$\lambda = 780 \text{ nm}$
Beam Uniformity = 0.05
Working Distance = 500 mm
Beam Profile:



CREOL – Beam shaper for microscopy

HIGH PERFORMANCE WITH UNIFORM ILLUMINATION IN (FLUORESCENCE) MICROSCOPY



- = College of Optics and Photonics/University of Central Florida (CREOL) worked on further development of a laser-based microscope set-up for uniform illumination
- = asphericon's TopShape and BeamExpander allow the transformation of Gaussian beams into a flat Top-Hat profile and thus the uniform illumination of the slide
- = Homogeneity of illumination: > 95 %

So Let's Shape YOUR Application

HIGH-RESOLUTION OPTICS AND SYSTEMS FOR YOU



**CHALLENGE
US!**







Sabrina Matthias

Product Manager

asphericon GmbH

Stockholmer Str. 9 | 07747 Jena

-  +49 - (0)3641-3100 500
-  +49 - (0)3641-3100 501
-  sales@asphericon.com
-  www.asphericon.de

